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# Wafer-Scale Fabrication of Sub-10 nm TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> n-p Heterojunctions with Efficient Photocatalytic Activity by Atomic Layer Deposition



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## Abstract

Wafer-scale, conformal, two-dimensional (2D) TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> n-p heterostructures with a thickness of less than 10 nm were fabricated on the Si/SiO<sub>2</sub> substrates by the atomic layer deposition (ALD) technique for the first time with subsequent post-deposition annealing at a temperature of 250 °C. The best deposition parameters were established. The structure and morphology of 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> n-p heterostructures were characterized by the scanning electron microscopy (SEM), X-ray photoelectron spectroscopy (XPS), electrochemical impedance spectroscopy (EIS), etc. 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> n-p heterostructures demonstrated efficient photocatalytic activity towards methyl orange (MO) degradation at the UV light ( $\lambda = 254$  nm) irradiation. The improvement of TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> *n*-*p* heterostructure capabilities is due to the development of the defects on Ga<sub>2</sub>O<sub>3</sub>-TiO<sub>2</sub> interface, which were able to trap electrons faster.

Keywords: TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub>, *n-p* heterostructures, atomic layer deposition, 2D semiconductors

## Background

Fabrication of 2D *p-n* heterojunctions of semiconductor oxides is one of the key directions of future development of nanostructures with unique distinguishable properties, as they are able to combine various outstanding features of both semiconductors at the nanoscale [1-4]. However, it is extremely challenging to fabricate them defects-free over the wafer area, particularly when the thickness of each oxide is only few nanometers [2]. In order to overcome numerous manufacturing challenges, ALD technology has already established clear and unprecedented advantages in the development of conformal nano- and monolayers of the semiconductor oxides and their 2D heterostructures with the thickness less than 10 nm on wafer-scale with high aspect ratio [3, 5-7]. In addition, various new approaches were also initiated

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More importantly, it was demonstrated that the decreasing free energy of the OER intermediates at the nano-interface would remarkably enhance the inherent electrochemical performance of catalyst [13]. In this regard, surface engineering is well illustrated to improve



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the accessibility of the reactants and to alter the electrochemical activity of the catalysts [14]. To achieve such enhancements of electrochemical properties of nanostructured heterostructures, various technological approaches have been utilized. Among them, the ALD technique can be used to deposit wafer-scaled nanomaterials with controlling their deposition rate at the Angstrom scale. Additional vital advantage of ALD is its self-limited nature by depositing materials in an atomic layer-to-layer [5, 6].

The alternative approach represents the development of 2D C-MOFs via the combination of "through-space" and "through-bind" strategies [14]. In particular, hexahydroxytriphenylene ligand-based 2D C-MOFs possess M-O4 (M-transitional metals) as their secondary building units and provide discrete metal-replicable layers as promising reactive sites for OER [14]. Moreover, these C-MOFs can remain stable in high pH solution, which is quite important for OER. Thus, all these above-mentioned recent advancements indirectly confirmed that no other technologies of making 2D nanostructures, including sol-gel, chemical vapor deposition (CVD), RF sputtering, etc., are capable to deliver uniformed deposition at the Ångstrom level over the large areas of Si/SiO<sub>2</sub> wafers with precise control of the deposition rate and thickness. Therefore, most of the developed recipes for ALD of 2D nanostructures using specific precursors possess valuable know-how and represent a highly repeatable process on the semi-industrial scale [5, 15, 16].

One of the main 2D semiconductors successfully utilized in the different photovoltaic applications is titanium dioxide  $(TiO_2)$ , which is a typical *n*-type semiconductor with wide bandgap  $E_g = \sim 3.2 \text{ eV} [5, 15-18]$ . There are numerous scientific reports focused on the different approaches for improvement of its properties such as changing thickness of nanostructured 2D TiO<sub>2</sub> down to monolayer [15, 16], doping  $TiO_2$  by other nanostructures semiconductors [5, 17], surface functionalization of 2D TiO<sub>2</sub> [18] and making *n*-*p* heterojunctions [19]. In addition, low electron/hole recombination is blamed for the low quantum yields, which is still a big obstacle for the improvement of photocatalytic activity. Therefore, fabrication of efficient *n*-*p* heterojunctions has been proposed and attempted with the different levels of success during the last few years [4, 17, 20–22]. Specifically, it was found that the fabricated n-pheterojunctions could sufficiently reduce the recombination rate of the photo-generated electron/hole pairs with the following enhancement of the overall photocatalytic activity [1, 23, 24]. Thus, the combination of *p*- and *n*-type semiconductor oxides has paved the way for the further development of *n*-*p* heterojunctions and optimization of their photocatalytic capabilities [25].

In this regard, 2D surface functionalization of 2D n-type TiO<sub>2</sub> by ALD of another p-type semiconductor

on the top of TiO<sub>2</sub> represents a unique strategy of making *n-p* heterojunctions and combining various outstanding properties of both semiconductors [5]. On the other hand, semiconductor oxides with a d<sup>10</sup> electron configuration have recently attracted considerable attention for their superior activities as potential dopant. This is mainly owing to their conduction bands being formed by hybridized *sp* orbits with a large dispersion, which enabled them to generate electrons with the large mobility [26]. Gallium oxide  $(Ga_2O_3)$ , as a typical representative of such d<sup>10</sup> semiconductor oxides, belongs to the group of transparent semiconducting oxides with a wide band gap and electrical conductivity. It exhibits the largest band gap with  $E_g = 4.8$  eV and thus a unique transparency from the visible into the UV region and good luminescence properties [27].  $\beta$ -Ga<sub>2</sub>O<sub>3</sub> is reported to be the most stable polymorph among five existing polymorphs of  $Ga_2O_3$  within the high-temperature range [28]. Moreover, nontoxic  $\beta$ -Ga<sub>2</sub>O<sub>3</sub> displayed significant potential for photocatalytic air purification, particularly for the elimination of toxic aromatic compounds [29]. Therefore, all these distinguishable properties of  $\beta$ -Ga<sub>2</sub>O<sub>3</sub> [30] substantiated a lot of efforts for the best suitable technologies of  $Ga_2O_3$  deposition at the nanoscale [31–33].

Notwithstanding the great attempts dedicated to the ALD of 2D semiconductor oxides during last few years, authors wish to stress that so far 2D  $\text{TiO}_2\text{-}\text{Ga}_2\text{O}_3$  *n-p* heterostructures with the thickness less than 10 nm have not yet been reported. In this work, 2D  $\text{TiO}_2\text{-}\text{Ga}_2\text{O}_3$  *n-p* heterostructures were ALD-fabricated on wafer-scale for the first time using  $\text{Ti}(\text{N}(\text{CH}_3)_2)_4$  and  $\text{C}_{33}\text{H}_{57}\text{GaO}_6$  as  $\text{TiO}_2$  and  $\text{Ga}_2\text{O}_3$  precursors, respectively. Their optimal deposition parameters were established and structural and photocatalytic properties were investigated.

## **Results and Discussion**

Figure 1 illustrates the fabrication process of 2D TiO<sub>2</sub>- $Ga_2O_3$  *n-p* heterostructures on the Si/SiO<sub>2</sub> substrate. Figure 2 schematically depicts the details of ALD depositions. After depositions, wafers were diced on  $1.0 \times 1.0$ cm segments (Fig. 2a) for further testing. For ALD 2D  $TiO_2$ -Ga<sub>2</sub>O<sub>3</sub> *n-p* heterostructures  $Ti(N(CH_3)_2)_4$  and C33H57GaO6 (Strem Chemicals Inc., USA) were used as  $TiO_2$  and  $Ga_2O_3$  precursors, respectively. Their graphical interpretations are given in Fig. 2b, c. The growth per cycle (GPC) yielded from the slopes of growth curves shown in Fig. 2d, e was calculated to be around 0.7 Å/cycle and 0.16 Å/cycle for TiO<sub>2</sub> and Ga<sub>2</sub>O<sub>3</sub>, respectively. The growth curves were linear without any nucleation delay for both TiO<sub>2</sub> and Ga<sub>2</sub>O<sub>3</sub> samples, implying that the self-limited property of ALD growth process and the film thickness could be developed precisely by varying the number of ALD cycles. The lower growth rate of 2D Ga<sub>2</sub>O<sub>3</sub> nano-films makes its



applications on the doping and modification possible [34]. Noteworthy, the optimal ALD deposition parameters for each precursor are usually established after several initial trials [6]. After each deposition cycle the variable angle in situ ellipsometry measurements (J.A. Woollam M2000 DI) were carried to monitor the uniformity and to measure the thickness of films. For example, Fig. 2f illustrates the in situ ellipsometry measurements for 2D TiO<sub>2</sub> with the average thickness of ~6.45 nm. Since the thickness measurements were found difficult on heterostructure, the Ga2O3 film growth was followed, using in situ ellipsometry measurement, on SiO<sub>2</sub>/Si substrate that was placed on the heater block, together with the sample. After the deposition, the Ga<sub>2</sub>O<sub>3</sub> film thickness on heterostructure was confirmed by comparing the amount of material deposited on it and the reference SiO<sub>2</sub>/Si using X-ray fluorescence measurements [19]. 2D Ga<sub>2</sub>O<sub>3</sub> films had an average thickness of  $\sim 1.5$  nm, which resulted in the total thickness of 2D TiO2-Ga2O3 heterostructures to be  $\sim 8.0$  nm. All fabricated samples were subsequently annealed in the air for 1 h at 250 °C with a heating rate of 0.5 °C/min.

Figure 3 shows SEM surface morphology images for both ALD-fabricated 2D TiO<sub>2</sub> (thickness ~ 6.5 nm) and

 $Ga_2O_3$  (thickness ~ 1.5 nm) nano-films. It is noteworthy that the TiO<sub>2</sub> nano-grains in the fabricated films were uniformly distributed over Si/SiO<sub>2</sub> wafer and varied in size from approximately ~ 30 to ~ 70 nm prior to  $Ga_2O_3$  deposition. Figure 3a depicts surface morphology of TiO<sub>2</sub> nano-film consisting of the flat nano-particles. Then, the ALD-developed ~1.5-nm-thick Ga2O3 nano-films were fabricated on the top of ~ 6.5-nm-thick TiO<sub>2</sub> nano-films. The ALD-developed sub-10 nm Ga<sub>2</sub>O<sub>3</sub>-TiO<sub>2</sub> heterostructures were subsequently annealed at 250 °C. Thus, Fig. 3b depicts crystalline surface morphology of the Ga2O3 in heterostructure after annealing. The Ga2O3 nano-film consists of uniformly distributed Ga<sub>2</sub>O<sub>3</sub> nano-grains with the average size from ~ 80 to ~ 110 nm. Owing to the extremely thin nature of the ALD-fabricated nano-films, employment of the X-ray diffraction technique for crystallinity investigation of these films was not possible.

Chemical composition and bonding states of 2D  $\text{TiO}_2$ -Ga<sub>2</sub>O<sub>3</sub> heterostructures were studied by XPS with Fig. 4a representing the  $\text{TiO}_2$ -Ga<sub>2</sub>O<sub>3</sub> heterostructure scan survey. The charge shift spectrum was calibrated for C1s peak at 284.8 eV. Three main elements of Ti, O, and Ga are clearly observed. In addition, C1s peak was also detected as it was originated from the reference to calibrate the binding energies of the peaks. Figure 4b



graph of thickness versus ALD cycle of Ga<sub>2</sub>O<sub>3</sub> films, respectively. **f** The spectroscopic ellipsometry mapping of thickness of 2D TiO<sub>2</sub> film

depicts high-resolution two quasi-symmetrical Ga  $2p_{1/2}$ and Ga  $2p_{3/2}$  peaks for Ga-O bonding at 1145.2 eV and 1118.4 eV with a separation distance of 26.8 eV, which is consistent with the binding energy of Ga 2p for doped  $\beta$ -Ga<sub>2</sub>O<sub>3</sub> [35, 36]. The weak energy peak for Ga 3d is centered at 21.1 eV, which is caused by the presence of Ga-O bond reported for *p*-type  $\beta$ -Ga<sub>2</sub>O<sub>3</sub> films [37], but not observed for the *n*-type  $\beta$ -Ga<sub>2</sub>O<sub>3</sub> structures [38]. The Ga 3d peak is asymmetrical, which was ascribed to the hybridization of Ga 3d and O 2s states near the valence band [39]. Figure 4c displayed the high-resolution scan of Ti 2p. The doublet peaks demonstrated in Fig. 4c correspond to Ti  $2p_{3/2}$  and Ti  $2p_{1/2}$  with the spin-orbital splitting of 6.2 eV, which were attributed to Ti<sup>+4</sup> oxidation state. It should be noted that the obtained XPS results in this investigation are slightly different from our previous report on the development of TiO<sub>2</sub> monolayer [15] and bi-layer [3] grown by ALD. This difference is reasonable considering the amount of Ti in the samples.

The O 1s peak in the XPS spectrum (Fig. 4d) could be deconvoluted into two major peaks. The main binding energy component centered at 531.53 eV is attributed to oxygen vacancies or  $OH^{-1}$  adsorbed species on the surface [38]. The second binding energy peak at 530.01 eV can be the characteristic of the lattice oxygen in the  $TiO_2$ -Ga<sub>2</sub>O<sub>3</sub> heterostructure. Very relevant to this investigation was

our previous study on ALD TiO<sub>2</sub> bi-layer confirming the influence of SiO<sub>2</sub> substrate, where the bottom oxygen of TiO<sub>2</sub> is shared with SiO<sub>2</sub> making 2D TiO<sub>2</sub> slightly non-stoichiometric [3]. Thus, this non-stoichiometry plays

a critical role in 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> heterostructure while the thickness of  $Ga_2O_3$  ALD on the top of TiO<sub>2</sub> is only ~ 1.5 nm. The enlarged energy peak for Ga 3d is presented in Fig 4e. Presence of Ga 3d peak in the spectrum is confirmation of the *p*-type conductivity for Ga<sub>2</sub>O<sub>3</sub> in the heterostructure, as being reported [37]. For further investigation of the conductivity type of 2D  $\beta$ -Ga<sub>2</sub>O<sub>3</sub>, additional 4.8-nm-thick Ga<sub>2</sub>O<sub>3</sub> samples were subjected to the Hall coefficient measurements at T = 25 °C. The measured Hall

coefficient value of  $8.292 \times 10^4$  cm<sup>3</sup>/C independently confirmed the stable *p*-type performance of 2D  $Ga_2O_3$ . Figure 5 expresses the plotted EIM measurements of the spectra for 2D TiO<sub>2</sub> (~ 3.5 nm), Ga<sub>2</sub>O<sub>3</sub> (~ 3.5 nm), and 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> heterostructures (~ 8.0 nm), respectively. EIS measurements were carried out in air at the

temperature of 25 °C and the impedance results were ob-

tained using the Randles equivalent circuit. It is note-

worthy that the fitted Nyquist plots in Fig. 5 revealed the

charge-transfer resistance ( $R_{ct} = 4.5 \text{ k}\Omega$ ) of 2D TiO<sub>2</sub>- $Ga_2O_3$  heterostructures with a thickness of ~ 8.0 nm being about 2.7-fold lower than that of ALD-developed 2D TiO<sub>2</sub>  $(R_{\rm et} = ~12.5 \text{ k}\Omega)$  and even slightly lower than that of 2D  $Ga_2O_3$  ( $R_{et} = \sim 6.0 \text{ k}\Omega$ ). This fact further designates that 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> heterostructures possess a much faster charge-transfer characteristics than that of 2D TiO<sub>2</sub> and Ga<sub>2</sub>O<sub>3</sub>. Although the measured impedance value for of  $Ga_2O_3$  was slightly higher than the reported value for 2D ALD-fabricated  $Ga_2O_3$  [40], this was partially due to the sub-nanometer thickness of the Ga<sub>2</sub>O<sub>3</sub> film [40] compare to the ~ 3.5-nm-thick Ga<sub>2</sub>O<sub>3</sub> in our experiments and was also partially owing to the fact that the developed 2D  $Ga_2O_3$  was not fully crystallized at the annealing temperature of 250 °C.

All FTIR spectra of 2D Ga<sub>2</sub>O<sub>3</sub>, TiO<sub>2</sub> and TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> *n-p* heterostructures are summarized in Fig. 6. As spectra for 2D TiO<sub>2</sub> and Ga<sub>2</sub>O<sub>3</sub> are nearly overlapping each other, they therefore were presented separately in Fig 6a and Fig. 6b, respectively, in comparison with the spectrum of 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> heterostructures. The peaks centered at about 1594 cm<sup>-1</sup> are attributed to the O-H stretching and bending modes of the hydrated oxide surface and the adsorbed water [41]. Moreover, the adsorption of atmospheric CO<sub>2</sub> on the surface of gallium oxide is characterized by the detection of bands at 1519 cm<sup>-1</sup> and 1646 cm<sup>-1</sup>, which resulted from preparation and processing of the samples in ambient air [42]. More interesting results were observed in the perturbation area, presented as inserts in Fig. 7a and Fig. 7b, respectively. The IR band at 607.9 cm<sup>-1</sup> is due to vibration of the Ga-O bond of  ${\rm GaO}_6$  octahedra in  ${\rm Ga}_2{\rm O}_3$  lattice [43]. Its intensity has the maximum in FTIR spectrum of 2D Ga<sub>2</sub>O<sub>3</sub> and decreased in the FTIR spectrum of 2D  $TiO_2$ -Ga<sub>2</sub>O<sub>3</sub> *n*-*p* heterostructure. Compared with the FTIR spectrum of 2D Ga<sub>2</sub>O<sub>3</sub> nano-film, a new peak at 464 cm<sup>-1</sup> appeared in FTIR spectrum for ALD-fabricated 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> n-p heterostructures. This peak is near overlapping typical characteristic peak at 470 cm<sup>-1</sup> for  $TiO_2$  [15].

Photoluminescence (PL) technique is usually employed to investigate the migration, transfer and recombination rate of the photo-induced electrons-holes pairs in semiconductors. Figure 7 shows the room temperature (25 °C) PL spectra of ALD-fabricated 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> n-p heterostructures annealed at 250 °C with the details of the measured bandgap for TiO<sub>2</sub> and Ga<sub>2</sub>O<sub>3</sub>, respectively. There are two peaks in the PL spectra for the 2D  $TiO_2$ -Ga<sub>2</sub>O<sub>3</sub> *n*-*p* heterostructures (presented in insert in Fig. 7): one is called near band edge emission (NBE), which is in the UV region due to the recombination of free excitons through an exciton-exciton collision process; and the second one is called deep level emission (DPE), which is caused by the impurities and/or





structural defects in the crystal [41]. The DPE intensity in 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> *n*-*p* heterostructures is lower than that in Ga<sub>2</sub>O<sub>3</sub> [44], which indicates more efficient transfer and separation of the charge carriers owing to the electron-hole transfer in the heterojunctions between  $TiO_2$  and  $Ga_2O_3$ . Noteworthy, the DPE of 2D  $TiO_2$ -Ga<sub>2</sub>O<sub>3</sub> *n*-*p* heterostructures is shifted towards the UV region whereas DPE of Ga<sub>2</sub>O<sub>3</sub> is within the visible light region [44]. In addition, the selected annealing temperature of 250 °C did not allow full crystallization of Ga<sub>2</sub>O<sub>3</sub> nano-film in the heterostructure, which was reflected by the unchanged value of its bandgap (4.8 eV). However, in our previous investigation, it was found that further increase of the annealing temperature (above 250 °C) of such extremely-thin films causes their disintegration with the following agglomeration of their nano-grains into island-like nanostructure [6]. On the contrary, the bandgap for  $TiO_2$  slightly changed to ~ 3.14 eV compared to its microstructural counterpart.

Consequently, all the above material characterization experiments clearly confirmed the successful, development of conformal and uniform sub-10 nm  $\text{TiO}_2\text{-}\text{Ga}_2\text{O}_3$ *n-p* heterostructures. Thus, these 2D  $\text{TiO}_2\text{-}\text{Ga}_2\text{O}_3$  *n-p* heterostructures were ALD-fabricated impurity-free on the wafer-scale and subsequently annealed at 250 °C for the establishment of developed *n-p* nano-interface.

The photocatalytic degradation of MO under the UV light irradiation ( $\lambda = 254$ nm) was carried out at the room temperature (25 °C) to evaluate the photocatalytic activity of ALD-fabricated 2D TiO<sub>2</sub>, Ga<sub>2</sub>O<sub>3</sub> and 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> *n-p* heterostructures. As presented in Fig. 8a, 2D

8

7

6

5

4

3

2

1

0

-1

0

Z" (KΩ)

**Z' (KΩ)** Fig. 5 Nyquist plots of the 2D TiO<sub>2</sub>, Ga<sub>2</sub>O<sub>3</sub>, and TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> heterostructures tested in air at a temperature of 25 °C

Δ

6

ż

Ga<sub>2</sub>O<sub>3</sub>

8

10

12

14

TiO<sub>2</sub>





 $TiO_2$ -Ga<sub>2</sub>O<sub>3</sub> *n-p* heterostructure demonstrated higher photocatalytic activity compared to both 2D  $TiO_2$  and Ga<sub>2</sub>O<sub>3</sub> under the same UV irradiation. Specifically, using 2D  $TiO_2$ -Ga<sub>2</sub>O<sub>3</sub> *n-p* heterostructure as the catalyst, MO degradation efficiency reached ~90% within 70 h, while the values for 2D Ga<sub>2</sub>O<sub>3</sub> and  $TiO_2$  were





approximately ~ 70% and ~ 65%, respectively, at the same time. Considering the fact that 2D Ga<sub>2</sub>O<sub>3</sub> has not been fully crystallized under the annealing temperature of 250 ° *C*, it is assumed that the weak chemical bond developed between 2D TiO<sub>2</sub> and Ga<sub>2</sub>O<sub>3</sub> is good enough to ensure the successful role of *n*-*p* heterojunction for the photocatalytic activity.

The photocatalytic degradation mechanism by 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> *n*-*p* heterostructure under  $\lambda$  = 245 nm UV light irradiation is proposed in Fig. 8b. It is a common knowledge that the photocatalytic degradation of dyes mainly involves several active radical species such as hydroxyl radicals ( $\cdot$ OH), holes (h<sup>+</sup>) and electrons (e<sup>-</sup>) [45]. The direct contact between 2D Ga<sub>2</sub>O<sub>3</sub> and TiO<sub>2</sub> induced the development of heterojunction owing to the different energy levels. Under  $\lambda$  = 254 nm UV light irradiation, both Ga<sub>2</sub>O<sub>3</sub> and TiO<sub>2</sub> were excited to generate electrons and holes simultaneously. Large numbers of defects consisting of robust acceptor state in the bandgap trap holes and prevent recombination. Various defect bands promote the electron-hole pair separation rate. The enhanced photo-catalytic performance is mainly derived from the large numbers of acceptor states accompany with Ga<sub>2</sub>O<sub>3</sub> defects especially in its not fully crystallized phase. The acceptor states not only expand the light absorption edge of UV but also retard the rate of electron-hole pair recombination. In this regard, both large number of defects and acceptor states is responsible for enhancing the photocatalytic performance of 2D TiO2-Ga2O3 n-p heterostructure. At the same time, holes in the VB of TiO<sub>2</sub> can migrate into the VB of Ga<sub>2</sub>O<sub>3</sub>. Thus, the concentration of photo-generated holes on the  $Ga_2O_3$  surface increases. The photo-generated holes play a vital role in the photo-degradation process of 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> n-p heterostructures. Therefore, the increasing concentration of the photo-generated holes in the VB of Ga<sub>2</sub>O<sub>3</sub> could also lead to its high photocatalytic activity. Moreover, the higher-specific surface area fabricated after annealing may additionally improve the overall photocatalytic activity of 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> n-p heterostructures. The absorption and desorption of molecules on the surface of the catalyst is the first step in the degradation process [46, 47]. Thus, higher surface-to-volume ratio in the surface morphology of the TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> n-p heterostructures provides more unsaturated surface coordination sites. Therefore, the annealed 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> n-p heterostructures possess higher-specific surface area caused by numerous ultrathin nano-grains, as presented in SEM characterization. Consequently, high surface-to-volume ratio combined with the suitable nano-interfaces obtained for the 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> n-p heterostructures resulted in its great photocatalytic activity towards the efficient MO degradation.

### Conclusions

In this work, wafer-scale 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> n-p heterostructures with the average thickness of  $\sim 8.0$  nm were successfully fabricated for the first time via a two-step ALD process by using Ti(N(CH<sub>3</sub>)<sub>2</sub>)<sub>4</sub> and C<sub>33</sub>H<sub>57</sub>GaO<sub>6</sub> as TiO<sub>2</sub> and Ga<sub>2</sub>O<sub>3</sub> precursors, respectively. Their optimal deposition parameters were established. The 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> *n-p* heterostructures were annealed at 250 °C for the structural stabilization and development of the n-pnano-interface. Subsequently, 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> n-p heterostructures were utilized for efficient MO degradation at the room temperature under the UV light ( $\lambda = 254$ nm) irradiation. 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> n-p heterostructures have clearly demonstrated unique capabilities and higher photocatalytic activity than that of pure 2D TiO<sub>2</sub> and  $Ga_2O_3$  for MO degradation. Specifically, the effect of *n*-*p* heterojunction between *n*-type  $TiO_2$  and *p*-type  $Ga_2O_3$ enabled a higher concentration of the photo-generated holes and larger-specific surface area, which ultimately led to its higher photocatalytic activity. Therefore, sub-10 nm, 2D n-p heterostructures can be potentially exploited as promising nano-materials for the practical photocatalytic devices.

## Methods

### Synthesis 2D n-p Heterostructure

All reagents and precursors were purchased from the commercial sources and represented analytical grade. They were used as received without further purification. The 4-in. Si/SiO<sub>2</sub> wafers (12  $\Omega$ /cm) were utilized as substrates for ALD depositions, where the thickness of the native oxide was ~1.78-1.9 nm. 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> n-p heterostructures were prepared by a two-step fabrication method. Prior to ALD depositions, in order to reduce the influence of Si wafer on electrical measurements, an additional ~ 100-nm-thick SiO<sub>2</sub> insulating layer was applied by CVD, (Oxford Instruments Plasmalab 100). After that 150-nm-thick Au/Cr films were deposited on SiO<sub>2</sub>/Si by the Electron Beam Evaporator method (Nanochrome II (Intivac, USA)) to develop electrodes for subsequent investigations. All ALD fabrications were carried out on Savannah S100 (Ultratech/Cambridge Nanotech). A pulse time of 5 s was used for both the  $Ga(TMHD)_3$  and  $O_2$  plasma, at a pressure of  $3 \times 10^{-3}$  mbar.

## Characterization

The surface morphology and elemental analysis of ALD-fabricated sub-10 nm  $TiO_2$ -Ga<sub>2</sub>O<sub>3</sub> heterostructures were characterized by scanning electron microscopy (SEM, SU-500) and energy dispersive X-ray (EDX) spectroscopy (EDS, JEOL). Fourier transform infrared (FTIR) spectra were taken using a NEXUS Thermo Nicolet IR-spectrometer in the range 4000–400 cm<sup>-1</sup> with a

spectral resolution 2 cm<sup>-1</sup>. In order to investigate the surface chemistries of the developed samples, X-ray photoelectron spectroscopy (XPS) was employed in the ESCALAB system with AlK X-ray radiation at 15 kV. All XPS spectra were accurately calibrated by the C1s peak at 284.6 eV for the compensation of the charge effect. Hall effect measurement system (HMS3000) was employed at the room temperature to measure the Hall coefficient of  $Ga_2O_3$  thin films by using a 0.55T magnet. EIS and all electrical measurements for 2D TiO<sub>2</sub>, Ga<sub>2</sub>O<sub>3</sub>, and TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> heterostructures were carried out on AutoLab PGSTAT204 (Metrohm Autolab, B.V., Netherlands). Room temperature photoluminescence (PL) spectra of ALD 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> heterostructures were performed on an F-4600 fluorescent spectrophotometer (Hitachi Corp., Tokyo, Japan), and the maximal excitation wavelength was  $\lambda = 200$  nm, and the filter was  $\lambda$  = 300 nm. The photocatalytic activity of 2D TiO<sub>2</sub>, Ga<sub>2</sub>O<sub>3</sub> and 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> heterostructures for the MO (C<sub>14</sub>H<sub>14</sub>N<sub>3</sub>NaO<sub>3</sub>S) degradation in aqueous solution under the UV light was evaluated by measuring the absorbance of the irradiated solution. For this study, 2D TiO<sub>2</sub>-Ga<sub>2</sub>O<sub>3</sub> heterostructures were placed into 100 mL of MO solutions with a concentration of 6 mg/L and a pH of 6.5. The solutions were continuously stirred in the dark for 2 h before illumination in order to reach the absorption-desorption equilibrium between MO and the 2D  $TiO_2$ -Ga<sub>2</sub>O<sub>3</sub> heterostructures. Then the solutions were irradiated by a 30 W low-pressure UV lamp ( $\lambda$  = 254 nm), which was located at the distance of 50 cm above the top of the dye solution. During the process, 5 mL solutions were pipetted every 12 h for the absorbance determination by a UNIC UV-2800A spectrophotometer using the maximum absorbance at 465 nm. All experiments were performed under the ambient condition and room temperature. The degradation efficiency of MO was defined as

$$D = [(A_0 - A_t) / A_0] \times 100\%, \tag{1}$$

where *D* is degradation efficiency,  $A_0$  is the initial absorbance of MO solution, and  $A_t$  is the absorbance of MO solution after UV irradiation within the elapsed time *t*.

#### Abbreviations

EDS: Energy dispersive spectroscopy; FTIR: Fourier transform infrared; MO: Methyl orange; PL: Photoluminescence; SEM: Scanning electron microscopy; UV-vis: Ultraviolet-visible; XPS: X-ray photoelectron spectroscopy

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#### Availability of Data and Materials

The crystal structure and chemical bonding structure of the as-prepared samples were characterized by XPS (Fig. 4), electrochemical impedance spectroscopy (Fig. 5), FTIR (Fig. 6), and FL (Fig. 7) measurements. Surface morphology of the samples was investigated by SEM (Fig. 3). Photocatalytic tests were examined by UV light ( $\lambda$  = 254 nm) irradiation (Fig. 8).

#### Authors' Contributions

HX and SZ conceived the idea and designed the growth experiment and investigation process. HX, FH, and SW performed the growth experiments and photocatalytic tests. RMR and CD fabricated heterojunction samples by ALD. SW and HF performed FL and Raman tests. CX and SW performed FTIR, SEM, and XPS tests. HX, MW, LL, and SZ discussed all the results. HX, FH, CX, and SZ wrote the manuscript. All authors read, discussed, and corrected the manuscript, and approved the final manuscript.

#### **Competing Interests**

The authors declare that they have no competing interests.

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